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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number		10/035,387	
		Filing Date		12/28/2001	
		Applicant(s)		Kin Foong Chan et al.	
		Art Unit			
		Examiner Name		Unknown	
SHEET	1	OF	2	Attorney Docket Number	22397.266

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hm	B2	EP 0552953	28/07/93		

OTHER PRIOR ART

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume, issue number(s), publisher, city/country where published
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Examiner Signature	<i>Mac</i>	Date Considered	9/27/03
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